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# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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| Complete if Known | |
|---|---|
| Application Number | |
| Filing Date | |
| First Named Inventor | **Seong Han Kim, et al.** |
| Art Unit | |
| Examiner Name | |
| Attorney Docket Number | **06324 USA** |

Sheet **1** of **2**

## U. S. PATENT DOCUMENTS

| Examiner Initials* | Cite No.[1] | Document Number Number-Kind Code[2] (if known) | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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| | | US- 5,354,490 | 10/11/1994 | C. C. Yu, et al. | |
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## FOREIGN PATENT DOCUMENTS

| Examiner Initials* | Cite No.[1] | Foreign Patent Document Country Code[3] Number[4] Kind Code[5] (if known) | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear | T[6] |
|---|---|---|---|---|---|---|
| | | EP 0846742 A2 | 6/10/1998 | Europe | | ✓ |
| | | EP 1096556 A1 | 5/2/2001 | Europe | | ✓ |
| | | WO 01/21724 A1 | 3/29/2001 | World | | ✓ |
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| Examiner Signature | | Date Considered | 1/16/05 |
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| Examiner Name | |
| Attorney Docket Number | **06324 USA** |

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## NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. [1] | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T [2] |
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| | | D. ZEIDLER, et al., "Characterization of Cu Chemical Mechanical Polishing by Electrochemical Investigations," Microelectronic Engineering, 33, pp. 259-265 (1997). | ✓ |
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